



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: **Mamoru NAKASUJI et al.**

Serial No.: **10/619,192**

Group Art Unit: Not yet assigned

Filed: **July 15, 2003**

Examiner: Not yet assigned

Confirmation No.: **4935**

For: **ELECTRON BEAM APPARATUS**

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 CFR 1.97(b)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 9, 2004

Sir:

The attention of the Patent and Trademark Office is hereby directed to the document listed on the attached Form PTO-1449. One copy of the document is attached.

No fee or certification is required in connection with this Information Disclosure Statement, since it is being submitted prior to the issuance of a first official action on the merits or expiration of the three month period following the filing date (or the entry of the national stage) of the above-captioned application.

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

Serial No.: 10/619,192

The Commissioner is authorized to charge our Deposit Account No. 50-2866 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

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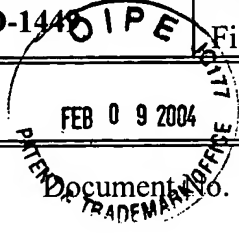
Atty. Docket No. 030865
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Enclosures: PTO-1449, 1 reference

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PATENT TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No.: 030865	Serial No.: 10/619,192
	Applicants: Mamoru NAKASUJI et al.	
	Filing Date: July 15, 2003	Group Art Unit: Not yet assigned



U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA	6,411,377	Noguchi et al.	06/25/2002	356 237.4	07/28/1999
_____	AB	6,593,152	Nakasuji et al.	07/15/2003	438 14	11/02/2001
_____	AC	5,892,224	Nakasuji	04/06/1999	250 310	05/09/1997, See page 1 in the spec.
_____	AD					
_____	AE					

FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)
_____ AF			
_____ AG			
_____ AH			
_____ AI			
_____ AJ			

OTHER DOCUMENTS

_____	AK	Shinada, H. et al. "High Speed and Large-Current Electron Optics for Wafer Inspection", Proceedings LSI Testing Symposium/2000 Conference Minutes, pp. 151-156
_____	AL	(English Translation is enclosed (Marked-up Portion Only)., Also see the page 1 in the spec.)
Examiner		Date Considered